# Accelerated Molecular Dynamics with the Bond Boost Method

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### Rare-Event Methods



#### **Rare-Event Simulation**

#### Kinetic Monte Carlo:

K. Fichthorn and W. Weinberg, J. Chem. Phys. **95**, 1090 (1991). Kinetic ART:

El-Mallouhi, N. Mousseau, Phys. Rev. B **78**,1532002 (2008). Master Equation

#### Search and Characterization

#### Nudged Elastic Band:

G. Henkelman, B.Uberuaga, and H. Jonsson,

J. Chem. Phys. 113, 9901 (2000).

#### Dimer Method:

G. Henkelman and H. Jonsson, J. Chem. Phys. **111**, 7010 (1999).

#### Transition Path Sampling:

P. Bolhuis, D. Chandler, et al. Ann. Rev. Phys. Chem. **53**, 291 (2002).

#### Forward-Flux Sampling:

R. J. Allen, D. Frenkel, P. R. ten Wolde, J. Chem. Phys. **124**, 194111 (2006). String Method:

W. E., W. Ren , E. Vanden-Eijnden, Phys. Rev. B **66**, 052301 (2002). AND.....

Molecular Dynamics Simulations Naturally Find Rare Events and Can Simulate Rare-Event Systems...

#### Accelerated Molecular Dynamics (Hyperdynamics)

\*

A

**Relative Rates** 

В

B

A. Voter, J. Chem. Phys. 106, 11 (1997).

$$k_{A\to B}^{TST} = \frac{1}{2} \frac{\int_A \delta_{AB}^* |v_{\perp,AB}| e^{-V(\mathbf{R})/k_B T}}{\int_A e^{-V(\mathbf{R})/k_B T}}$$

$$k_{A\to B}^{TST} = \nu \frac{\int \delta_{AB}^* W(\mathbf{R}) e^{-V(\mathbf{R})/k_B T} / W(\mathbf{R})}{\int W(\mathbf{R}) e^{-V(\mathbf{R})/k_B T} / W(\mathbf{R})}$$

$$W(\mathbf{R}) = \exp\left(\frac{V(\mathbf{R}) - V(\mathbf{R})}{k_B T}\right)$$

$$k_{A\to B}^{TST} = \nu \frac{\int \delta_{AB}^* e^{-V(\mathbf{R})/k_B T} / \int e^{-V(\mathbf{R})/k_B T}}{\int e^{-V(\mathbf{R})/k_B T} / W(\mathbf{R}) / \int e^{-V(\mathbf{R})/k_B T}}$$

#### Accelerated Molecular Dynamics (Hyperdynamics)



# Accelerated Molecular Dynamics

R. Miron & K. Fichthorn, J. Chem. Phys. 119, 6210 (2003)

Define Local Minima by Bond Lengths

 $\{r_i^o\}_{i=1,N}$ 

Transitions Occur via Bond Breaking

$$\max_{i} \left| \frac{\delta r_{i}}{r_{i}^{o}} \right| > q$$
 Empirical Threshold

Boost the Bonds: Purely Geometric





## Details of the Bond Boost Method

### **Boost Potential**

$$\Delta V(\mathbf{r}) = \frac{\Delta V_{\max}}{N} A(\varepsilon_{\max}) \sum_{i=1}^{N} \delta V(\varepsilon_{i})$$

$$\varepsilon_i = \frac{\delta r_i}{r_i^0}$$

#### Nominal Boost per Bond

$$\delta V\left(\varepsilon_{i}\right) = 1 - \left(\frac{\varepsilon_{i}}{q}\right)^{2}$$

Envelope: Channels Boost into the Bond Most Ready to Break

$$A(\varepsilon_{\max}) = f \times \left[1 - \left(\frac{\varepsilon_{\max}}{q}\right)^2\right]$$



# **Overview of the Bond Boost Method** R. Miron & K. Fichthorn, J. Chem. Phys. 119, 6210 (2003) find local minimum (conjugate-gradient minimization) detect transition ... MD on boosted PES $\delta t = \delta t_{simulation} e^{\beta \Delta V}$ MD on boosted PES detect transition , find new state

### Diffusion on Cu(100): Elementary Processes



Adatom Hop



Adatom Exchange



**Dimer Exchange** 



**Dimer Hop** 



Vacancy Hop

R. Miron & K. Fichthorn, *J. Chem. Phys.* **119**, 6210 (2003)

### The Bond-Boost Method: Diffusion on Cu(100)

$$k = \frac{N_{events}}{time} = \Gamma_0 e^{-\beta E_A}$$

R. Miron & K. Fichthorn, *J. Chem. Phys.* **119**, 6210 (2003)

Prefactors  $\Gamma_0(\text{THz})$  and activation energies  $E_A(\text{eV})$ :

Process	$\Gamma_0^{boost}$	$\Gamma_0^{MD}$	$E_A^{boost}$	$E_A^{MD}$	$E_A^{static}$	
	$(\times e^{\pm 0.7})$	$(\times e^{\pm 0.6})$	$(\pm 0.05)$	$(\pm 0.04)$		
Adatom hop	40	20	0.52	0.49	0.51	
Adatom exchange	270	437	0.73	0.70	0.71	
Vacancy hop	54	27	0.44	0.47	0.44	
Dimer hop	30	13	0.47	0.48	0.49	
Dimer exchange	190	320	0.71	0.73	0.69	

#### boost accelerated MD at T = 230 - 600 K

Rates :

 $^{MD}$  regular MD at T = 650 - 900 K  $\rightarrow$  Boisvert, Lewis *Phys.Rev.* B 65 (1997)  $^{static}$  using Step-and-Slide method  $\rightarrow$  Miron, Fichthorn *J.Chem.Phys.* 115 (2001)

#### The Bond-Boost Method: Diffusion on Cu(100)

Boost = Physical Time / Simulation Time



## Hut Formation in AI(110) Homoepitaxy



### Accelerated AIMD (VASP): Diffusion on Al/Al(110)



Climbing-Image Nudged Elastic Band Method

VS. **Accelerated** 

**AIMD** 



 $E_{R} = 0.38 \text{ eV}$ 

Fichthorn *et al., J. Phys. Cond. Matt.* **21**, 084212 (2009).



 $E_{B} = 0.33 \, \mathrm{eV}$ 

## The Boost in ab initio MD



### Rare Events and the Small Barrier Problem

Co on Cu(100) surface with tight-binding (TBSMA) potential (Levanov *et al.*, *Phys. Rev.* B 61, 2000)

TST barriers:  $\Delta E^{\dagger} = 0.66 \, eV$  for isolated adatom hop  $\Delta E^{\dagger} = 0.86 \, eV$  for isolated adatom exchange

#### **Annoyingly Small Barriers**



 $\Delta E^{\dagger} = 0.2 \, eV$   $10^{6}$  faster (T = 350K)than isolated hop



# State-Bridging Accelerated MD to Solve the Small-Barrier Problem



R. Miron, K. Fichthorn, Phys. Rev. Lett. 93, 2004.

Raise the

## Co on Cu(001): Benefits of State Bridging



State-Bridging Accelerated MD Regular Accelerated MD

#### Thin Film Growth at 250 K, F = 0.1 ML/s



R. Miron, K. Fichthorn, Phys. Rev. Lett. 93, 2004.

Note Cluster Mobility

## State-Bridging Accelerated MD of Co/Cu(001) Heteroepitaxy: T = 250 K, F = 0.1 ML/s, $\Theta = 0.54$ ML MD Simulations were run for 5.4 s



R. Miron and K. Fichthorn, *Phys. Rev. B* **72**, 115433 (2005). Mechanism of Bilayer Island Formation

## **Temperature-Programmed Desorption**

K. Becker, M. Mignogna, K. Fichthorn, *PRL* **102**, 046101 (2009).



 $T = T_0 + \beta t$ 



**12**, 203 (1962).

# Simulation of TPD



#### Large Molecules Don't Work in Lattice Models....



Goal: To Simulate TPD with Accelerated MD!!

## Accelerated MD of Adsorbed Alkanes



**OPLS All-Atom Force Field [1]** 

$$V_{intra} = V_b + V_t + V_{LJ}$$
$$V_b(\theta_i) = K_\theta (\theta_i - \theta_{eq})^2$$
$$V_t(\varphi_i) = \frac{1}{2} \sum_{j=1}^3 V_j [I + \cos(j\varphi_i)]$$

Constrained Bond Stretching: RATTLE [2]

Steele's Potential for Molecule-Surface Interaction [3]

Jorgensen et al., J. Am. Chem. Soc. 118, 11225 (1996)
 H.C. Andersen, J. Comput. Phys. 52, 24 (1983)
 W. A. Steele, Surf. Sci. 36, 317 (1973)

### Many Local Minima, Fast Transitions But Desorption is the Slow Step









# Accelerated MD of TPD with the Bond-Boost Method

$$\Delta V(\mathbf{R}) = \frac{A(\varepsilon_{\max})}{N} \sum_{i=1}^{N} \delta V_i(\mathbf{R}) ; \quad \delta V_i = (\alpha_1 - 1) V_{s,i} + (\alpha_2 - 1) V_{inter,i}; \quad \alpha_i < 1$$

Weaken Molecule-Molecule + Molecule-Surface Attraction

$$A = \left[ 1 - \left( \frac{\varepsilon_{\max}}{q} \right)^2 \right]; \qquad \varepsilon_i = \frac{z_{com,i} - z_{eq}}{z_{eq}}$$

Funnels Boost into Molecule Farthest from the Surface

$$t = \sum_{i} \exp\left(\frac{\Delta V(\mathbf{R}_{i})}{k_{B}T}\right) \Delta t$$

K. Becker, M. Mignogna, K. Fichthorn *PRL* **102**,046101 (2009).

## Accelerated MD of TPD



K. Becker, M. Mignogna, K. Fichthorn, *PRL* **102**, 046101 (2009).

desorptions

## **TPD:** Simulation vs. Experiment



PRL 102, 046101 (2009).

# Desorption Energy And Prefactor



Large prefactors because of loss in rotational entropy on adsorption.

K. Fichthorn and R. Miron, *Phys. Rev. Lett.* **89**, 196103 (2002).
K. Becker and K. Fichthorn, *JCP* **125**, 184706 (2006).



# Second-Layer Desorption Can Occur At (Sub) Monolayer Coverage



#### Rate Processes in Pentane Desorption



K. Becker, M. Mignogna, K. Fichthorn, *PRL* **102**, 046101 (2009).

# What is the Structure of a Real GaAs(001)β2(2x4) Surface?



		(2x4)	••	•	••	•	•• ••	•	••	•	••	•	
		Unit Cell	••	•	••	•	•••	•	••	•	••	•	
	STM		••	•	•• ••	•	••	•	••	•	••	•	
			••	•	•• ••	•		•	•••	•	••	•	
			Нур	oot	hes	sis	: D	iso	orde	rir	ıg		
	D.W. Pashley, J.H. Neave, B.A.	Joyce,	Invo Dov		es	Sh പ	liftir From	ig (	of L	١m	ner		
	Suit. Sci. <b>582,</b> 189 (2005)		<b>NOV</b>	VS	an	uI	IEI	ICI	162				



How Does this Surface Disorder? What Does This Mean for Diffusion and Growth??

K. A. Fichthorn, et al., Phys. Rev. B, 83, 195328 (2011)

# Regular MD of GaAs (001): T = 600 K



## Minimum-Energy Path for Row Shift: Another Form of the Small-Barrier Problem



## Accelerated MD Simulation at 800 K



# Equilibrium Fraction of $\beta 2(2x4)$ and $c(2 \times 8)$ from 1 $\mu$ s - 4 s Accelerated MD









(a)  $\gamma = 68.73 \text{ meV/Å}^2$  (b)  $\gamma = 68.71 \text{ meV/Å}^2$ (a) and (b)  $\beta 2(2 \times 4)$ 

900K 850K 800K 700K 600K β2(2×4)  $0.43 \pm 0.03$  $0.45 \pm 0.03$  $0.44 \pm 0.03$  $0.42 \pm 0.15$  $0.46 \pm 0.13$ c(2×8)  $0.52 \pm 0.03$  $0.52 \pm 0.03$ 0.54±0.03 0.58±0.15  $0.53 \pm 0.13$ Others  $0.053 \pm 0.003$ 0.031±0.005  $0.019 \pm 0.002$  $0.007 \pm 0.003$  $0.008 \pm 0.008$ 



#### Comparison with Experiment

STM (300K, UHV)

 $\beta^{2}(2 \times 4)$  **0.41**; c(2×8) **0.52**; Other **0.07** 

RHEED (850 K As Over Pressure, 300 K Vacuum) No Difference

D. W. Pashley, J. H. Neave, and B. A. Joyce, Surf. Sci. **582**, 189 (2005)

(c)  $\gamma = 68.68 \text{ meV}/\text{Å}^2$  (d)  $\gamma = 68.67 \text{ meV}/\text{Å}^2$ 

(c) and (d)  $c(2\times 8)$ 

Arrangement based on STM image

## **Conclusions: Progress in Accelerated MD**

- The Bond-Boost Method is Useful for Modeling and/or Discovering Rare Events
- The Challenge is Dealing with the Small-Barrier Problem in a General Way
  - Consolidating Pools of Shallow States

     R. Miron & K. Fichthorn, Phys. Rev. Lett. 93, 2004;
     Phys. Rev. B72, 035415, 2005.



## **Conclusions: Progress in Accelerated MD**

- Bond = Order Parameter
   K. Becker, M. Mignogna, K. Fichthorn, *PRL* 102, 046101 (2009)
- Pathway Boost for GaAs(001) Y. Lin and K. Fichthorn, in preparation.



The key to future progress is a general solution to the small barrier problem

Look for our **NEW SOLUTION** to the Small-Barrier Problem Using KMC+Master Equation!!!!

# Collaborators

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